Study of Two-Dimentional Array Piezoelectric Inkjet Head

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ABSTRACT

In science and technology change with each passing day of the modern society, it is Inkjet printing technology, in last few years change more diverse, the level that it apply will more is extensive, as modern style fuel system, liquid crystal display, the optical communication equip and MEMS devices etc, can by this technique to reduce cost and raise the efficiency of manufacturing process. In many kinds of inkjet printing technology, an important type of inkjet printing technology is the piezoelectric driven printing technology. In this report, the adoption drives meeting with shear to transform mode with the round radial of PZT, will this with the result that move a two-dimentional array piezoelectric Inkjet head and can be all spraying all nozzle mouths liquid drop in the meantime to insure this to press to give or get an piezoelectric Inkjet head, to this with the result that spray all nozzle mouths if can control together in a r two-dimentional array piezoelectric Inkjet head after, will design a drive wave form, to control the make it can reach single signal to drive to reach inkjet make to move, and ability jet the whole slice of 5*5 arrays are single of liquid drop.

Keywords : Piezoelectric, Array, Inkjet Head, Waveform

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